



16569 U.S.

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Mail Stop Patent Application
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

16834 U.S. PTO
10/825831

Re: Inventor(s): **Gondhalekar et al.**
Title: **GAS DELIVERY SYSTEM FOR SEMICONDUCTOR PROCESSING**

Transmitted herewith is the patent application identified above, including:

Specification, claims and abstract, totaling 21 pages
 Drawings totaling 4 pages, Formal X Informal
 Executed Declaration and Power of Attorney
 Assignment of the invention to Applied Materials, Inc. and Assignment Recordation Cover Sheet
 Return Receipt Postcards (2)

FEE CALCULATION

Fee Items	Claims Filed	Included with Basic Fee	Extra Claims	Fee Rate	Total
Total Claims	20	- 20 =	0	x 18.00	\$ 0.00
Independent Claims	3	- 3 =	0	x 86.00	\$ 0.00
Basic Filing Fee				770.00	\$770.00
TOTAL FEES					\$ 770.00

The Commissioner is hereby authorized to charge \$ 770.00 to Deposit Account No. 50-1074.
 The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment to Deposit Account No. 50-1074. A duplicate copy of this transmittal is enclosed.
 Please address all future correspondence to: **APPLIED MATERIALS, INC.**
Patent Department, M/S 2061
P.O. Box 450A
Santa Clara, CA 95052

Respectfully submitted,

Robert W. Mulcahy
Registration No. 25,436

Express Mail Label No: EV341109456US Date of Deposit: APRIL 16, 2004